

Notice of References Cited

Application/Control No.

10/692,173

Applicant(s)/Patent Under
Reexamination
CHEN ET AL.

Examiner

Haoshian Shih

Art Unit

2173

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,807,668 b2	10-2004	Stern et al.	719/329
*	B	US-5,586,025	12-1996	Tsuji et al.	715/500
*	C	US-6,560,608 b1	05-2003	Tomm et al.	707/102
*	D	US-6,212,577 b1	04-2001	Stern et al.	719/329
*	E	US-2003/0135476 A1	07-2003	Holland et al.	706/47
*	F	US-2004/0027382	02-2004	Kuehn et al.	345/769
*	G	US-2004/0181753	09-2004	Michaelides, Phyllis J.	715/523
*	H	US-5,283,856	02-1994	Gross et al.	706/47
*	I	US-5,579,521	11-1996	Shearer et al.	719/329
*	J	US-6,324,498	11-2001	Wajda, Wieslawa	703/25
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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